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Docket No.: 10156-US-PA

AMENDMENT

In the Claims:

1. (currently amended) A split-gate non-volatile memory cell, comprising:

a substrate;

a charge-trapping layer on the substrate;

a split gate as a whole located over the charge-trapping layer, being a part of

one word line of a non-volatile memory array including the split-gate non-volatile

memory cell; and

a source/drain in the substrate beside the split gate,

wherein the split gate includes at least two neighboring conductive pieces that

are shorted with each other and have two opposite edge portions together causing, in

operation of the memory cell, a locally stronger electric field such that only one

coding region is defined, by the two neighboring conductive pieces, in the charge-

trapping layer around the two opposite edge portions.

Claims 2-3: (cancelled).

4. (previously presented) The split-gate non-volatile memory cell of claim 1,

wherein the conductive pieces of the split gate include a pair of conductive spacers

and a conductive layer between the pair of conductive spacers.

5. (original) The split-gate non-volatile memory cell of claim 4, wherein the

pair of conductive spacers are arranged with two substantially vertical sidewalls

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thereof adjacent to the source/drain.

6. (original) The split-gate non-volatile memory cell of claim 5, further

comprising an insulator on the source/drain, wherein the pair of conductive spacers

are disposed on the sidewalls of the insulator.

Claim 7: (canceled).

8. (previously presented) The split-gate non-volatile memory cell of claim 1,

wherein the conductive pieces are separated from each other by a dielectric layer.

9. (original) The split-gate non-volatile memory cell of claim 1, wherein the

split gate comprises polysilicon.

10. (original) The split-gate non-volatile memory cell of claim 1, wherein the

charge-trapping layer comprises a silicon nitride layer disposed between two silicon

oxide layers.

11. (original) The split-gate non-volatile memory cell of claim 1, wherein the

charge-trapping layer comprises aluminum oxide (Al₂O₃).

12. (original) The split-gate non-volatile memory cell of claim 1, wherein the

substrate comprises a p-substrate, and the source/drain comprises an n-type

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source/drain.

Claims 13-34: (cancelled).

35. (currently amended) An operating method of a split-gate non-volatile memory

cell, wherein

the split-gate non-volatile memory cell comprises:

a substrate;

a charge-trapping layer on the substrate;

a split gate as a whole located over the charge-trapping layer, being a part of one

word line of a non-volatile memory array including the split-gate non-volatile memory

cell; and

a source/drain in the substrate beside the split gate,

wherein the split gate includes at least two neighboring conductive pieces that are

shorted with each other and have two opposite edge portions together causing, in

operation of the memory cell, a locally stronger electric field such that only one coding

region is defined, by the two neighboring conductive pieces, in the charge-trapping layer

around the two opposite edge portions;

and the operating method comprises:

in a programming operation:

applying 0V to the substrate and the source/drain; and

applying a first negative voltage to the split gate, the first negative voltage being

sufficiently high for injecting electrons into the coding region; and

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in an erasing operation:

applying 0V to the split gate, wherein each conductive piece is at an electric state

of 0 V;

floating the source/drain; and

applying a second negative voltage to the substrate, the second positive voltage

being sufficiently high for ejecting electrons from the coding region.

36. (original) The operating method of claim 35, wherein the first negative

voltage is about -10V.

37. (original) The operating method of claim 35, wherein the second negative

voltage is about –10V.

Claims 38-45: (cancelled).

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